

Toyota Technological Institute
Graduate School of Engineering

Admission Guidelines for Students of National Chung Hsing University
for Double Degree Program
<For enrollment in April 2027>

1. Admission Capacity:

Four (4)

2. Fields of Research/Education:

- Mechanical Systems Engineering
- Electronics and Information Engineering
- Materials Science and Engineering

Choose one from among the laboratories in the list attached.

3. Admission Requirements:

Applicants must be graduate students enrolled at a university with which the Double Degree Program has been established, and also must be recommended by the department chair of the home university.

4. Language Skills:

Applicants are required to have at least one of language skills listed below at the time of the application for admission. Applicants must submit the original copy of the official score report for either English or Japanese.

(1) English Skills:

TOEIC® L&R score of 600 or higher, or TOEFL iBT® score of 62 or higher

(2) Japanese Skills:

JLPT N2 or higher

* Classes and examinations are generally conducted in Japanese.

5. Financial Requirement:

Applicants must have sufficient financial means to cover at least 120,000 JPY per month (1,440,000 JPY per year) for their living expenses throughout the duration of their studies in Japan.

6. Application Procedure:

Applicants are required to submit the following documents (1)-(6):

(1) Application Form for Admission (form provided)

Prior to filling in the name of a laboratory which you hope to work in, contact the professor (who you wish to work with) and obtain the consent that you will put the laboratory name down in the application form.

* Please check if the laboratory can accept Double Degree students or not. Some professors may not accept students in a given year.

(2) Certificate of Enrollment

Official transcripts with authorized signature or seal.

Please attach a Japanese or an English translation if the original documents are written in languages other than Japanese or English.

(3) Academic Records, Graduate and Undergraduate

Official transcripts with authorized signature or seal.

Please attach a Japanese or an English translation if the original documents are written in languages other than Japanese or English.

(4) Letter of Recommendation (form provided)

To be written by the department chair of the home university.

(5) TOEFL, TOEIC, or JLPT Score Record

The original copy of TOEFL Official Score Report, TOEIC Official Score Certificate, or JLPT Certificate of Result and Scores.

(6) Declaration of Applicable Specific Categories (form provided)

In accordance with the amendments to the "Deemed Export" regarding security export control (November 2021, Foreign Exchange and Foreign Trade Act), in order to confirm whether the item is subject to control, the declaration document with relevant information and signature must be completed based on the "Flowchart for determining applicable specific categories."

* A student visa needs to be ready before you enroll in the institute

* Please be advised that in the course of enrollment procedures or other administrative matters, all or part of the submitted application documents may be provided to public authorities, such as the Immigration Services Agency, if a formal request for information is made.

7. Submission of Application Documents:

Admissions Office
Toyota Technological Institute
2-12-1 Hisakata, Tempaku-ku
Nagoya, JAPAN 468-8511
Tel : +81-52-802-1111
Fax : +81-52-809-1721

8. Application Period:

All application documents must be sent via postal mail and reach TTI no later than
Friday, October 23, 2026.
(We do not accept the documents sent by e-mail.)

9. Selection Procedures:

Applicants will be admitted based on the submitted documents.

10. Notification of Results:

Applicants will be notified of the results of acceptance as soon as the selection has been
finished.

11. Date of Enrollment:

New academic year starts in April.

List of laboratories (Contact addresses for further information)

*Please add @toyota-ti.ac.jp

	Laboratories	Name	Position	E-mail *
Mechanical Systems Engineering	Fluid Engineering	Tarou Handa	Prof.	handa
	Aerodynamics and Space Transportation	Yasumasa Watanabe	Assoc. Prof.	yswatanabe
	Thermal Fluid Dynamics	Hiroki Yamaguchi	Prof.	hiroki
	Computational Mechanics	Yoshinori Shiihara	Prof.	shiihara
	Design Engineering	Masakazu Kobayashi	Assoc. Prof.	kobayashi
	Innovative Machine	Katsushi Furutani	Prof.	furutani
	Mechanical Material Engineering	Takuma Shiga	Assoc. Prof.	shiga
	Micro-Nano Mechatronics	Minoru Sasaki	Prof.	mnr-sasaki
		Deqing Kong	Assoc. Prof.	kong
	Biomedical and Mechanical Engineering	Takeshi Okuyama	Prof.	t-okuyama
Electronics and Information Engineering	Semiconductor	Yoshio Ohshita	Prof.	y_ohshita
	Functional Semiconductor Devices	Toshinori Numata	Prof.	numata
		Sho Nakosai	Assoc. Prof.	nakosai
	Photovoltaic Devices	Nobuaki Kojima	Lecturer	nkojima
	Laser Science	Takao Fuji	Prof.	fuji
	Nano Optical Science	Tetsuhiro Kudo	Assoc. Prof.	kudo
	Spintronics	Kenji Tanabe	Prof.	tanabe
	Control System	Michihiro Kawanishi	Assoc. Prof.	kawa
	Information and Communications	Yojiro Mori	Prof.	mori
	Computational Intelligence	Yutaka Sasaki	Prof.	yutaka.sasaki
	Intelligent Information Media	Norimichi Ukita	Prof.	ukita
	Knowledge and Data Engineering	Makoto Miwa	Prof.	makoto-miwa
Materials Science and Engineering	Optical Functional Materials	Takenobu Suzuki	Prof.	takenobu
	Energy Materials	Tsunehiro Takeuchi	Prof.	t_takeuchi
	Correlated Electron Materials	Masaharu Matsunami	Prof.	matunami
	Theoretical Physics	Tsunehide Kuroki	Prof.	kuroki
	Mathematical Physics	Shinya Tomizawa	Prof.	tomizawa
	Surface Science	Masamichi Yoshimura	Prof.	yoshi
		Masanori Hara	Assoc. Prof.	haram
	Polymer Chemistry	Kenta Kokado	Prof.	kokado
	Catalytic Organic Chemistry	Yukihiro Motoyama	Prof.	motoyama